잉크젯 프린팅 공정을 이용한 3D Integration 집적 기술의 무소결 고충진 유전체막 제조

Inkjet Printing Process to Fabricate Non-sintered Low Loss Dielectric 1 nick rums with rugn racking Density for 3D Integration Technology

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Abstract: We have successfully demonstrated the inkjet printing process to fabricate Al₂O₃ thick films without a high temperature sintering process. A single solvent system had a coffee ring pattern after printing of Al₂O₃ dot, line and area. In order to fabricate the smooth surface of Al₂O₃ thick film, we have introduced a co-solvent system which has nanosized Al₂O₃ powders in the mixture of Ethylene glycol monomethyl ester and Di propylene glycol methyl ether. This co-solvent system approached a uniform and dense deposition of Al₂O₃ powders on the substrate. The packing density of inkjet-printed Al₂O₃ films is more than 70% which is very high compared to the value obtained from the films synthesized by other conventional methods such as casting processes. The characterization of the inkjet-printed Al₂O₃ films has been implemented to investigate its thickness and roughness. Also the dielectric loss of the films has been measured to understand the feasibility of its application to 3D integration package substrate.

Key Words: Inkjet printing, dielectric thick film, packing density, co-solvent system